

Inventor: Jane Buehler

Title: Methods of Treating Physical Vapor Deposition Targets

Assignee: Honeywell International, Inc.

Attorney Docket No. HO001499-DIV1

Jc971 U.S. PTO  
10/081757  
02/19/02

**INFORMATION DISCLOSURE STATEMENT**

**PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

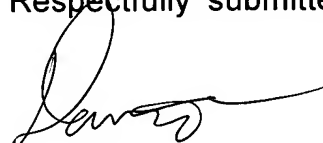
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/687,947, filed October 13, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Dated: 2/19/02

Respectfully submitted,



David G. Latwesen, Ph.D.  
Reg. No. 38,533

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. HO001499-DIV1		Priority SERIAL NO. 09/687,947	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT J. Buehler		Priority FILING DATE October 13, 2000	
				Priority GROUP 1753			
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	3,630,881	12/71	Lester et al.			
	AB	3,985,635	10/76	Adam et al.			
	AC	4,551,216	11/85	Argyo			
	AD	5,336,386	08/94	Marx et al.			
	AE	5,538,603	07/96	Guo			
	AF	5,658,442	08/97	Van Gogh et al.			
	AG	5,753,090	05/98	Obinata			
	AH	6,086,735	07/00	Gilman et al.			
	AI	5,632,869	05/97	Hurwitt et al.			
	AJ	5,282,943	02/94	Lannutti et al.			
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes      No
	AM	06 306597	11/94	Japan			
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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